

Docket No.: 49657-961

REQUEST FORM FOR CONTINUATION APPLICATION UNDER 35 USC 111(a)

Prior Application: International Application No. PCT/JP00/03337
Art Unit: (Unassigned)
Examiner: (Unassigned)

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

This is a Request for filing a continuation or continuation-in-part application, entitled X-RAY EXPOSURE APPARATUS, X-RAY EXPOSURE METHOD, X-RAY MASK, X-RAY MIRROR, SYNCHROTRON RADIATION APPARATUS, SYNCHROTRON RADIATION METHOD AND SEMICONDUCTOR DEVICE, under 35 U.S.C. 111(a) of pending prior International Application No. PCT/JP00/03337, filed on May 24, 2000, entitled X-RAY EXPOSURE APPARATUS, X-RAY EXPOSING METHOD, X-RAY MASK, X-RAY MIRROR, SYNCHROTRON RADIATOR, SYNCHROTRON RADIATING METHOD, AND SEMICONDUCTOR DEVICE, by the following named inventors:

INVENTOR	RESIDENCE	CITIZENSHIP	POST OFFICE ADDRESS
Kenji ITOGA	TOKYO, JAPAN	Japanese	c/o Mitsubishi Denki Kabushiki Kaisha, 2-3, Marunouchi 2-chome, Chiyoda-ku, TOKYO 100-8310 JAPAN
Toyoki KITAYAMA	TOKYO, JAPAN	Japanese	c/o Mitsubishi Denki Kabushiki Kaisha, 2-3, Marunouchi 2-chome, Chiyoda-ku, TOKYO 100-8310 JAPAN

1. ☒ I hereby verify, to the best of my knowledge, that the enclosed copy of this prior application is a true copy of the above-identified prior application, including the oath or declaration as originally filed.
2. ☐ Preliminary Amendment is enclosed.
- 2a. ☒ An Information Disclosure Statement and PTO1449 Form are submitted herewith.
3. ☐ Cancel claims



20277

PATENT TRADEMARK OFFICE

4. The filing fee is calculated on the basis of the claims existing in the prior application as amended at 3 above:

	NO. OF CLAIMS		EXTRA CLAIMS	RATE	AMOUNT
Total Claims	45	-20	25	\$18.00 =	\$450.00
Independent Claims	6	-3	3	\$80.00 =	\$240.00
Basic Application Fee					\$710.00
If multiple dependent claims are presented, add \$270.00					\$0.00
Total Application Fee					\$1400.00
Subtract ½ if small entity					\$0.00
TOTAL APPLICATION FEE DUE					\$1400.00
AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT NO. 500417					\$1400.00

- 4a. ☐ Enclosed is a Verified Statement to establish small entity status under 37 CFR 1.9 and 37 CFR 1.27.
- 4b. ☐ A verified Statement to establish small entity status under 37 CFR 1.9 and 37 CFR 1.27 was filed in prior application and such status is still proper and desired.
5. ☒ The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 which may be required, including any extension of time fees including any extension of time fees to maintain the pendency of the parent application Serial No. ___ or credit any overpayment to Deposit Account No. 500417.
6. ☐ Amend the specification by inserting before the first line the sentence:
7. ☒ Priority of Japanese Patent Application Serial No. 11-149621 filed on May 28, 1999, in Japan and International Application No. PCT/JP00/03337 filed May 24, 2000 designating the U.S. is claimed under 35 USC 119, 120 and/or 365. A certified copy of the Japanese priority document will follow. Also enclosed is a copy of the front page of the published International Application (WO 00/74119).
8. ☒ The prior application is assigned of record to Mitsubishi Denki Kabushiki Kaisha of Tokyo, Japan and Canon Kabushiki Kaisha of Tokyo, Japan
9. ☒ The power of attorney in the prior application is to:

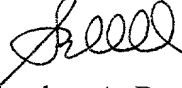
Fukami Patent Office

10. ☐ Also enclosed:
11. ☐ A petition, fee and response has been filed to extend the term in the pending prior application until .
12. ☒ Address all future communications to: (May only be completed by applicant, or attorney or agent of record)

McDERMOTT, WILL & EMERY
600 13th Street, N.W.
Washington, DC 20005-3096

Respectfully submitted,

McDERMOTT, WILL & EMERY


Stephen A. Becker
Registration No. 26,527

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 SAB:klm
Date: January 26, 2001
Facsimile: (202) 756-8087